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Complete if Known

Application Number	10/525824
Filing Date	01/17/2008
First Named Inventor	David L. Bender
Art Unit	1722
Examiner Name	
Attorney Docket Number	SOLAICX 004

Sheet

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NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	1	C. WANG et al.; A Continuous Czochralski Silicon Crystal Growth System; Journal of Crystal Growth 250 (2003), pgs. 209-214	
	2	HOPKINS et al.; Crystal Growth Considerations in the Use of "Solar Grade" Silicon; Journal of Crystal Growth 42 (1977) 493-498	
	3	M. H. LEIPOLD et al.; Materials of Construction for Silicon Crystal Growth; Journal of Crystal Growth 50 (1980) 366-377	
	4	I. F. CISZEK et al.; Silicon Materials Research on Growth Processes, Impurities, and Defects; NREL Conference March, 2003	
	5	I. WANG; Shallow Melt Czochralski Growth of Semiconductor Silicon; NREL, Golden, CO; Aug. 5, 2003	

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